

AS1 (Untitled 1)
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2003

Doc#	Document ID	Issue Date	Page#	Title	Current OR	Current XRef	Inventor	U	3	C	P	PT2
1	US 20050056537 A1	20050317	35	Planarization of substrates using electrochemical mechanical polishing	204/229.4		Chen, Liang-Yuh et al.	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
2	US 20050042478 A1	20050224	72	Magnetoresistance effect element, its manufacturing method, magnetic	428/694TM	428/694TS	Okuno, Shiho et al.	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
3	US 20050006244 A1	20050113	17	Electrode assembly for electrochemical processing of workpiece	205/148	204/275.1	Uzoh, Cyprian E. et al.	<input type="checkbox"/>	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
4	US 20050000818 A1	20050106	39	Method, chemistry, and apparatus for noble metal electroplating on a	205/102		Graham, Lyndon W. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
5	US 20040266327 A1	20041230	31	Conductive polishing article for electrochemical mechanical polishing	451/526		Chen, Liang-Yuh et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
6	US 20040235406 A1	20041125	163	Abrasive agglomerate coated raised island articles	451/527	51/300	Duescher, Wayne O.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
7	US 20040226510 A1	20041118	54	Semiconductor processing apparatus having lift and tilt mechanism	118/719		Hanson, Kyle et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
8	US 20040222086 A1	20041111	23	Electroplating reactor including back-side electrical contact apparatus	204/297.01	204/297.06; 204/297.08	Woodruff, Daniel J. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
9	US 20040188259 A1	20040930	24	Tuning electrodes used in a reactor for electrochemically processing a	205/83	205/123	Wilson, Gregory J. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
10	US 20040188257 A1	20040930	19	Methods for processing micro-feature workpieces, patterned structures on	204/478	205/188; 205/205	Klocke, John et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
11	US 20040169963 A1	20040902	73	Magnetoresistance effect element, its manufacturing method, magnetic	360/324.1	428/693	Okuno, Shiho et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
12	US 20040134792 A1	20040715	57	Conductive polishing article for electrochemical mechanical polishing	205/640	257/821.304	Butterfield, Paul D. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>

3/2005 SN 09/910,481 EPO, JPO, IBM TDB search

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L2: (82320) wafer or wafers					
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L4: (26951) cup or cups					
L5: (10436) bowl or bowls					
L6: (8) L1 and L2 and L3 and L4					
L7: (463283) L1 or L2					
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